



Xerox Docket No. D/97317

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Cathie J. BURKE et al.

Application No.: 10/046,245

Group Art Unit: 1756

Filed: January 16, 2002

Docket No.: 106452

For: METHODS OF PATTERNING RESISTS AND STRUCTURES INCLUDING THE  
PATTERNEDE RESISTS

**REQUEST FOR APPROVAL OF DRAWING CORRECTIONS**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to Figures 3-6, marked in red on the attached copy of such drawing figures.

Upon approval by the Examiner, and upon allowance of this application, the formal drawings will be corrected.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Jacob A. Doughty  
Registration No. 46,671

**RECEIVED**  
APR 15 2002

**TC 1700**

JAO:JAD/ldg

Date: April 10, 2002

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400